Design Guide Outline for System Integration

1. Chemical Injection System Field Architecture
2. Cavitation
3. Requirement of a Shut-off Valve Downstream of the CIMV
4. Coupler Tubing Volume Requirement
5. Chemical Compatibility
6. Measurement Accuracy
7. Minimum Pressure Drop Requirements
8. Chemical Injection Line Sizing
9. FAQs and Lessons Learned
10. Response Time and Flow Delivery Accuracy
11. Terms and Definitions
12. Axioms

“Final truth of your flow rate is the change in your tank level”
The Design Guide is written with a system level design approach in mind. The information gathered is from our customers, vendors, and most importantly SkoFlo’s 26 years of chemical injection experience.

SkoFlo has written this section to help any engineer design and develop a chemical injection system.

“You’ve got to think about big things while you’re doing small things, so that the small things go in the right direction.”

-Alvin Toffler

1. Chemical Injection System Field Architecture

Figure 1 shows a typical Surface Chemical Injection Distributed System in combination with a Subsea Back Pressure Regulator on one injection point.
Pump is rated 10% more than the total rate injected.

Surface BPRs spill off excess fluid that subsea or surface CIMVs do not flow.

Flows greater than .5 gpm continuous flow and over 5,000psi. A multistage Surface BPR is recommended to address cavitation damage and emitted noise.

Fluids thicker than 30cP will extend the allowable range before cavitation is a maintenance and operational concern. Thin fluids such as Methanol will reduce the maximum flow allowable with a single trim internal to the CIMV.

Injection Point 4 as shown in Figure 1 depicts a Surface CIMV in combination with a Subsea BPR. A Subsea BPR (see section for Subsea BPR in the catalog for more details) is gas charged to a pressure more than 500psi of the fluid column height. This gas charge is pre charged at a factory setting depending on the customer requirement.

Filtration requirements for a Topside and Subsea Chemical Injection System

- Filters on topside act as early warning systems for chemicals congealing.
- Filter openings topside should be smaller than last chance screens installed subsea and/or the smallest opening in the hydraulic couplers.

Heat Exchanging Considerations – Chemical tank topside

- Variable Frequency Drives (VFD) are recommended to reduce required size of surface BPRs and minimize spill off, lowering the heat input to chemical storage tanks.
- Tank temperatures up to 150°F are easily achieved if excess spill off and insufficient heat exchange is provided. 150°F fluid causes evaporation of bases or solvents, that in turn, causes the chemical to have increased viscosity when injected and/or change the chemical properties with respect to its intended use.
- Temperature rises approximately 9°F for every 10,000psi from the suction to the discharge of a pump and will rise an additional 9°F for every 10,000psi when spilling back to tank though a BPR thus creating a net temperature gain of approximately 18°F for fluid returning to the chemical tank.
2. Cavitation

Cavitation is a phenomenon that can accompany the flow of liquids through control valves. Simply viewed, cavitation consists of the formation, growth, and rapid collapse of cavities in a liquid. These vapor cavities (bubbles) are formed whenever the prevailing fluid pressure falls below the vapor pressure of the liquid. They subsequently collapse if the pressure again rises above the vapor pressure. Unacceptable noise levels, excessive vibrations, and physical damage to the valve and adjacent hardware are the foremost problems associated with cavitation. These problems all arise from the collapse of the vapor cavities. Material damage results from shock waves and micro-jets, established during cavity collapse, impinging on the boundary surfaces. Not all cavitation necessarily results in the problems mentioned above. However, attempts to model the behavior of the cavitating liquid have not met with universal success. Distinguishing “problem causing” cavitation from acceptable behavior presents some very real challenges.

The cavitation index, in effect, quantifies only the service conditions. By itself it does not convey any information about the performance of a particular valve in that particular application. Different valves can tolerate different levels of cavitation.

SkoFlo CIMVs

The primary pressure drop in the SkoFlo Low Flow CIMV is over the pin and seat. The pin rides on the Pressure-Balanced Piston. The $\sigma_{mr}$ (recommended cavitation index) of the SkoFlo CIMV is 2 or if the pressure drop across the CIMV exceeds the outlet pressure.

Maximum continuous pressure drop must not exceed outlet pressure to avoid cavitation. This rule corresponds to a cavitation index $\sigma$ of two or more across the piston and seat or 3,000 psi (206.8 bar) maximum drop.

$$\sigma = \frac{\text{Inlet Pressure}}{\text{Inlet Pressure} - \text{Outlet Pressure}} > 2.0$$

3. Requirement of a Shut-off Valve downstream of the CIMV

A shutoff valve must be positioned after the outlet of the CIMV core to provide a common mode zero of the pressure sensors, hereafter referred to as a field zeroing.

SkoFlo CIMVs

- Allows calibration of chemicals subsea for CIMVs configured with a PDFM. Without the field zeroing, larger flow rate inaccuracies are encountered for flow by dP readings only.

4. Coupler Tubing Volume Requirement

Pressure build up is caused by mating hydraulic couplers if the shutoff valve is in close proximity of the inlet and outlet of the docking receptacle.

Recommended practices:

- To prevent pressure buildup in injection lines, provide enough stretch in the fluid lines by increasing the volume of the tube to and from the CIMV to the nearest shutoff valve. It allows more fluid to share the compression load.

SkoFlo CIMVs

- Tubing volume between downstream of the CIMV outlet coupler and downstream isolation valve should be a minimum of 36 cubic inches for a Low Flow CIMV and 127 cubic inches for a High Flow CIMV.
5. Chemical Compatibility
Material compatibility of CIMV (chemically and seawater wetted) components is key to the reliability and longevity of valves.

Recommended Practices:
- All metallic parts are free of yellow metals (bronze, brass, copper and its alloys), to the risk of preventing galvanic corrosion and wear off.
- All chemically wetted materials should be evaluated for chemical compatibility prior to deploying Subsea against the project specific chemicals.

SkoFlo CIMVs
For elastomeric seals, SkoFlo utilizes high reliability material grades such as perfluoroelastomers which have a chemical resistance comparable to PTFE (Fluoropolymer) and is qualified for exposure to harsh environments with wide temperature ranges and is recommended by the industry for challenging oil and gas non-metallic sealing applications.

Individual Seal materials are rigorously tested and approved based on Rapid Gas Decompression (RGD).

6. Adjustment accuracy, % reading and % rated full scale for flow measurements
Measurement accuracy as percent of reading is defined as the difference between the reported flow through the CIMV and the actual flow. Percent of Rated Full Scale (RFS) is the measured flow compared to the rated full scale flow of the valve. SkoFlo uses percent of reading for Low Flow CIMVs and percent of RFS for High Flow CIMVs.

Adjustment Accuracy is defined as the ability of the valve to drive the stem to the set flow rate.

SkoFlo CIMVs
Once the flow rate is initially set on a SkoFlo CIMV, the motor driven stem does not need to move to regulate flow for changes in pressure or fluid conditions. The mechanical pressure balanced piston regulates flow at the set rate.

Low Flow CIMV
Measurement accuracy (% of reading):
- Flow by PDFM = \left( \frac{\text{Flow by PDFM} - \text{Reference}}{\text{Reference}} \right) \times 100
- Flow by dP = \left( \frac{\text{Flow by dP} - \text{Reference}}{\text{Reference}} \right) \times 100
- Flow by Stem = \left( \frac{\text{Flow by Stem} - \text{Reference}}{\text{Reference}} \right) \times 100

Adjustment Accuracy (% of reading):
- Flow by dP = \left( \frac{\text{Flow by dP} - \text{Target Flow Rate}}{\text{Target Flow Rate}} \right) \times 100
- Flow by Stem = \left( \frac{\text{Flow by Stem} - \text{Target Flow Rate}}{\text{Target Flow Rate}} \right) \times 100
- Flow by PDFM = \left( \frac{\text{Flow by PDFM} - \text{Target Flow Rate}}{\text{Target Flow Rate}} \right) \times 100

High Flow CIMV
Measurement accuracy (% RFS):
- Flow by dP = \left( \frac{\text{Flow by dP} - \text{Reference}}{\text{RFS}} \right) \times 100
- Flow by Stem = \left( \frac{\text{Flow by Stem} - \text{Reference}}{\text{RFS}} \right) \times 100

Adjustment Accuracy (% RFS):
- Flow by dP = \left( \frac{\text{Flow by dP} - \text{Target Flow Rate}}{\text{RFS}} \right) \times 100
- Flow by Stem = \left( \frac{\text{Flow by Stem} - \text{Target Flow Rate}}{\text{RFS}} \right) \times 100

7. Minimum Pressure Drop Requirements for a SkoFlo CIMV
Minimum Pressure Drop Requirement for a SkoFlo CIMV is to energize the patented Pressure-Balanced Piston, which maintains constant flow rate regardless of fluctuations in supply or well pressure.

- Surface NMFE (Minimum dP: 500 psi)
- Surface SF5000C and SF10000DRS and SFHTD valves (Minimum dP: 250 psi)
- Subsea Low Flow CIMVs (Minimum dP: 250 psi)
- Subsea High flow CIMVs (See High Flow Product Datasheet on page 24)

8. Chemical Injection Line sizing for constant rate control devices
When using rate controls that maintain constant flow, Cv values are not relevant with respect to entering losses of valves using solvers for branched flow lines.

Recommended Practices:
- Calculate the loss in psi per foot using the minimum pressure drop across the CIMV at the maximum anticipated flow for the most viscous fluid anticipated.
- Most umbilicals are too long to develop turbulent flow to flush lines during commissioning.

54 DESIGN GUIDE
9. Lessons Learned

- In general, chemical inhibitors have an affinity to metallic parts. This affinity increases filling, causing a reduction of flow through throttling components.
- Filters on surface protect chemicals from clogging and line filming when openings are smaller than those downstream. A last chance filter in a sub sea rate control warns against the onset of chemicals congealing.
- The Mean Time To Failure (MTTF) of Positive Displacement Flow Meters (PDFMs) are significantly extended when not continuously activated.
- The most common cause of a malfunctioning rate control is misapplication.
- A non-cavitating ceramic trim will endure longer than ten piston pump rebuilds.
- In the event of loss of power or communication, Fail as-is without drift is more cost effective than Fail as-is.
- New design mechanisms are tested on surface rigs for at least two years of continuous use before subsea installation.
- Hermetically sealed bellows endure longer and outperform a stem packing.
- Throttling Trim will cavitate if the pressure drop across the CIMV exceeds the outlet pressure.
- Most chemical blockages are caused by congealing chemicals rather than accumulation of particulate debris.
- Chemical properties differ in Subsea and Topside environments.
- Valve selection must start with a system level approach.

Sealing: chemical to seawater and/or electronics enclosure
- Metal to metal seals are recommended for primary seals.
- Avoid using O-rings as primary pressure containing seals due to the potential of gas decompression.
- Cup seals have potential for egress.

On-site training:
- Because SkoFlo CIMVs are flow regulators with a minimum pressure drop, proper system training and setup are critical. Untrained offshore technicians will often mistakenly try to operate a SkoFlo CIMV as a standard orifice valve or choke.

10. Response Time & Flow Delivery Accuracy

Steadiness of flow delivery is important, not just measurement accuracy. The flow rates could vary significantly from target rate but average over an extended period of time. An erratic delivery is not an optimal way to inject chemicals.

SkoFlo CIMV mechanical Pressure-Balanced Piston will open and close within milliseconds to shed debris and film while maintaining delivery at set flow rate regardless of pressure fluctuations. The pressure-balanced piston is an instantaneous control loop.

Typical flow profile of a needle and seat valve with throttling controlled by a motor is shown in Figure 3. The SkoFlo CIMV is shown alongside, maintaining a flow delivery accuracy of +/- 5% of reading and not going outside of the flow delivery tolerance range.

With competitive chemical injection valves, filming, debris clearing, and pressure fluctuations require long response times to move the stem up and back to the set-point, and then confirm flow by waiting for update counts from a flow meter. The SkoFlo CIMV does not operate this way, response time is nearly instantaneous, and flow rate is maintained without feedback needed from the flow measurement device.
Variable Orifice and Pressure-Balanced Piston

**Pressure-Balanced Piston** is an instantaneous control loop that will open and close within milliseconds to maintain a constant pressure drop across the cascading orifice.

At low flows such as 10 GPD other designs can take several minutes to open and close to respond to pressure fluctuations, filming, and debris.

**Variable orifice** is comprised of cascading passages allowing particles to pass without interrupting flow. Ceramic coating on orifice surfaces enhances resistance to filming.

**Pin and Seat** will lift off 0.015” to pass class 12b-f debris SAE 4059 fluid.

Designs that utilize characterized needles require long travel times to open and clear debris then return to previous position.

Positive Displacement Flow Meter (PDFM)

SkoFlo developed a flow meter that will maintain accuracy and not clog over a 25 year life.

A compliant disc will seal against a seat and shed debris without damage to the disc or seat as opposed to rotary vane flow meters that stall with hard debris.

**Flow measurement piston** moves only 0.7 inches and updates flow within .001 inches of travel.

Wiper cups protect the cup seal that encloses the flow to be measured.

PDFM only needs to be activated once per hour because the rate control provides constant flow without feedback from the flow measured device compared to competitors design with constantly rotating parts that can significantly affect reliability.

---

High Flow Chemical Injection Metering Valve

The instantaneous control loop provided by SkoFlo CIMVs Pressure-Balanced Piston adjusts to maintain stable and constant flow counteracting changes in pressure drop across the device.

For competing designs individual flows are monitored by “smart” valves adjusting a motor drive to open or close a valve trim.

- These installations are based on the assumption that pressure drops across parallel branches will be similar. Start-ups involve tweaking software to teach the valves not to fight each other. Later significant changes to the system or operating conditions can effect these teach settings.
- Inlet pressure oscillations to one valve cause instability in other branches. This cause and effect cyclic action is exemplified by rapid changes in outlet pressure caused by gas breaking out of the well’s fluid column.

---

56 DESIGN GUIDE
11. Terms and Definitions

**Absolute Filtration:** The absolute rating is the diameter of the largest spherical glass particle which will pass through the filter. The absolute rating reflects the pore opening size of the medium. Filter media with an exact and consistent pore size have an exact absolute rating.

**Back Pressure Regulator (BPR):** BPRs regulate the higher inlet (upstream) pressure by opening up only as much as necessary to hold back the desired pressure at the inlet (upstream). BPRs work just like relief valves, but the emphasis is on steady state pressure control instead of on/off pressure protection.

**Brownfield:** An existing onshore or offshore facility, e.g. ‘brownfield modification’ is an upgrade to an existing facility.

**CANbus:** A network communication protocol developed to communicate to the instrument.

**Cathodic Protection (CP):** CP is a technique used to control the corrosion of a metal surface by making it the cathode of an electrochemical cell.

**Centipoise (cP):** cP is a measure of dynamic viscosity.

**Centistokes (cSt):** cSt is a decimal fraction of the CGS unit of kinematic viscosity stokes, which is equal to centimeter per second (cm²/s). 1 stokes is a kinematic viscosity of a fluid with a density of 1 g/cm³ and a dynamic viscosity of 1 poise.

**Check Valve:** A check valve, clack valve, non-return valve or one-way valve is a valve that normally allows fluid (liquid or gas) to flow through it in only one direction.

**Compressibility:** Compressibility is a measure of the relative volume change of a fluid or solid as a response to a pressure (or mean stress) change.

**Congealing:** Process where chemicals thicken, gel (jelly-like) or solidify into a blocking element.

**Cup Seal:** Fluid control element normally directional in nature to allow for motion.

**Design Life:** Design life of a component or product is the period of time during which the item is expected by its designers to work within its specified parameters.

**Electron Beam Welding (EBW):** EBW is a fusion welding process in which a beam of high-velocity electrons is applied to two materials to be joined. The workpieces melt and flow together as the kinetic energy of the electrons is transformed into heat upon impact.

**Fail as-is without drift:** Upon loss of power, CIMV continues to regulate flow at the last set flow rate regardless of pressure fluctuations, line debris and filming.

**Fail as-is:** Upon loss of power, CIMV remains at the last set position.

**Fail-open:** Device opens at loss of power.

**FIlming:** Formation of a thin layer of chemical to exposed CIMV surfaces.

**Flow Delivery Accuracy:** The percentage variation of the flow rate delivered as compared to the target flow rate.

**Flow Measurement Accuracy:** The percentage variation of measurement of flow rate as compared to actual flow rate.

**Gas Tungsten Arc Welding (GTAW):** GTAW, also known as tungsten inert gas (TIG) welding, is an arc welding process that uses a non-consumable tungsten electrode to produce the weld.

**Greenfield:** A new field development requiring new facilities, either onshore or offshore.

**Holding Tank:** Holding tank is used to store chemical, having material properties that are compatible with the chemical being stored.

**Hysteresis:** The difference between up-scale and down-scale results in instrument response when subjected to the same input approached from the opposite direction. Hysteresis can be caused by a multitude of variables, such as packing friction, loose linkage and pressure drop.

**Impingement Angle:** Angle between the fluid and the wall controlling element.

**Incompressible Flow:** Density of a fluid element does not change during its motion. Density variation are not linked to the pressure.

**Inrush Current:** Maximum, instantaneous input current drawn by an electrical device when first turned on.

**Mass flow rate:** Mass of a substance which passes per unit of time.

**Modbus:** A serial communication protocol developed to communicate to the instrument.

**Mean Time Between Failure (MTBF):** Average amount of time that a device or product functions before failing.

**Mean Time To Failure (MTTF):** Length of time a device or other product is expected to last in operation.

**Multi Quick Connect (MQC):** MQC is fitted to flying lead and jumper umbilicals, enabling hydraulic and electrical connection between subsea control equipment such as umbilical termination assemblies, distribution units and wellhead Christmas trees.

**Newtonian Fluids:** A fluid when viscosity is constant for different rates of shear and does not change with time.

**Nominal Filtration:** A nominal rating indicates the filter’s ability to prevent the passage of a minimum percentage of solid particles greater than the nominal rating’s stated micron size.

**Non-Newtonian Fluids:** A fluid when viscosity varies with the rate of shear or varies with time, even though the rate of shear is constant.

**Perfluoroelastomer (FFKM):** Effectively a rubber form of PTFE. They are commonly used to make O-rings and gaskets that are used in applications that involve contact with hydrocarbons or highly corrosive fluids, or when a wide range of temperatures is encountered.

**Positive Displacement Flow Meter (PDFM):** PDFMs are volumetric flow measurement instruments ideal for low flow rates, highly viscous fluids, and measurement of flows involving starts and stops or pulsing.
Pressure Compensator: Pressure compensators are used to maintain preset pressure differential across a hydraulic component to minimize the influence of pressure variation on a flow rate passing through the component.

Pressure Containing: A part whose failure to function as intended results in a release of retained fluid to the environment.

Pressure Controlling: A part which is intended to control or regulate the movement of pressurized fluid.

Pressure Gauge: A device used to monitor pressure level in the pump discharge line.

Pressure Regulator: A pressure regulator is a valve that automatically cuts off the flow of a liquid or gas at a certain pressure.

Pressure Retaining: A part which maintains pressure containing elements, normally not in contact with the primary fluid.

Pressure Safety Valve (PSV): PSV is either spring loaded, normally closed, adjustable valve or burst plate used to allow fluid to exit from the pump discharge line when pressure reaches Maximum Allowable Working Pressure (MAWP).

Primary seals: First barrier which retains fluid to the environment.

Pulsation Damper: Pulsation Damper is used to decrease pressure spikes in pump discharge caused by piston type pumps. Can be bladder type or piston type. Bladder type is more efficient for eliminating pump pulsation in fluid stream.

Pump: A Pump usually a positive displacement type, should have sufficient capacity to satisfy all injection demand PLUS 10%, should have sufficient pressure rating to satisfy design requirements.

ROV Mate: Electrical connector intended to be mated or plugged in by ROV or diver.

Secondary Seals: Redundant barrier to primary seal which retains fluid to the environment.

SIIS: Subsea Instrumentation Interface Standardization.

Stab Mate: Electrical connector intended to be mated when Junction plates are mounted.

Subsea Control Module (SCM)/Control Pod: The SCM/Control Pod is the interface between the control lines, supplying hydraulic and electric power and signals from the host facility, and the subsea equipment to be monitored and controlled. The pod contains electronic components that are used for control, communications and data-gathering.

Vapor Pressure: Pressure exerted by a vapor when the vapor is in equilibrium with the liquid or solid form, or both, of the same substance—i.e., when conditions are such that the substance can exist in both or in all three phases. Vapor pressure is a measure of the tendency of a material to change into the gaseous or vapor state, and it increases with temperature.

Viscosity: Viscosity is a measure of a fluids resistance to gradual deformation by shear stress or tensile stress.

Viscosity, Dynamic: Dynamic Viscosity is a measure of internal resistance.

Viscosity, Kinematic: Kinematic viscosity can be obtained by dividing the absolute viscosity of a fluid with the fluid mass density.

Volumetric flow rate: Volume of fluid which passes per unit time.

12. Axioms

Final truth of your flow rate is the change in tank level.

A test is worth a thousand expert “opinions”.

Never attempt to fool Mother Nature, mimic whenever possible.

If you don’t understand the design limits, it will lead to misapplication.

The best designs are simple rather than complex and are created from a collaboration of experts who remain with the project from conception to field installation.

Optimal chemical injection results are achieved with continuous rather than batch injection.

Viscosity, pressure drop, and outlet pressure are the most significant factors when predicting the onset of cavitation.

Due to line loss and compressibility, the most accurate control is achieved when the regulating device is closest to injection point.

Never get into an argument with someone who types faster than you.
SkoFlo maintains accreditation to international quality standard ISO 9001-2008

SkoFlo Industries, Inc.
14241 NE 200th Street
Woodinville, WA 98072 USA
1-425-485-7816

www.skoflo.com

SkoFlo maintains accreditation to international quality standard ISO 9001-2008